



Attorney's Docket No.: 14225-050001 / F1040151US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyoshi Mita
Serial No. : 10/814,063
Filed : March 31, 2004

Art Unit : 2829
Examiner : Asok K. Sarkar
Confirmation No.: 5478
Notice of Allowance Date: 12/7/2004

Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

MAIL STOP ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

OIC to
entru
AKS
11/18/05

AMENDMENT AFTER ALLOWANCE
PURSUANT TO 37 C.F.R. §1.312

Please amend the application as indicated on the following pages. This amendment is being filed concurrently with the payment of the issue fee.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

March 7, 2005

Signature

Paula T. Romeo

PAULA T. ROMEO

Typed or Printed Name of Person Signing Certificate